

EE4371 - Introduction to MEMS

[EE 4371](#) Introduction to MEMS (3 semester credit hours) The goal of this course is to provide an introduction to M/NEMS fabrication techniques, selected device applications, and the design tradeoffs in developing systems. Prerequisites: ([MECH 3310](#) and [MECH 3350](#) and [PHYS 2126](#) and [PHYS 2326](#)) or ([CE 3310](#) or [EE 3310](#)). (Same as [MECH 4370](#)) (3-0) Y